

SD-2

Glass Substrate for Silicon Sensors

PRODUCT DESCRIPTION

HOYA's SD-2 substrate is designed with a coefficient of thermal expansion curve which closely matches Si single crystal.

THERMAL EXPANSION PROPERTIES

Borosilicate glass has been widely used as a bonding material to Silicon Wafer. CTE curves of Borosilicate glass and Silicon Single Crystal Wafer cross at about 240°C. When anodic bonding is performed at 400°C, the difference of the expansions at high temperature creates residual stress in the Si chip during cooling to room temperature. As precision of LSI circuit patterning moves to less than 0.25 microns, distortion between the silicon and glass wafers becomes a critical issue.

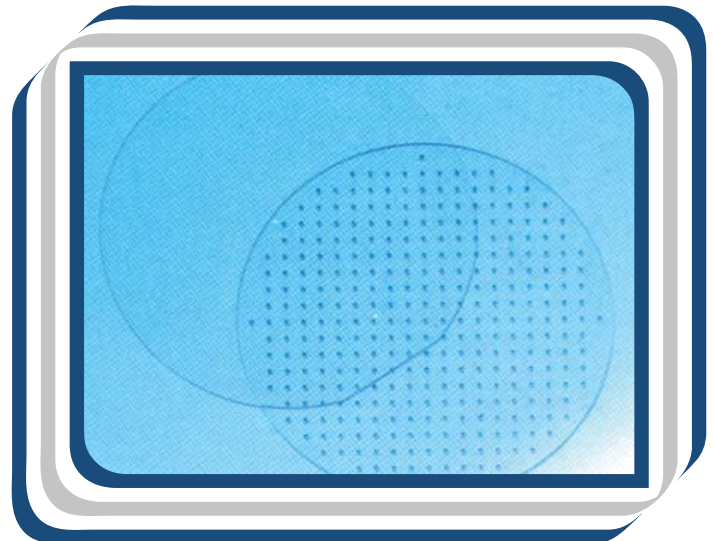
HOYA's SD-2 substrate is engineered to minimize the distortion or bowing effect caused by the thermal mismatch between the two wafers.

ANODIC BONDING

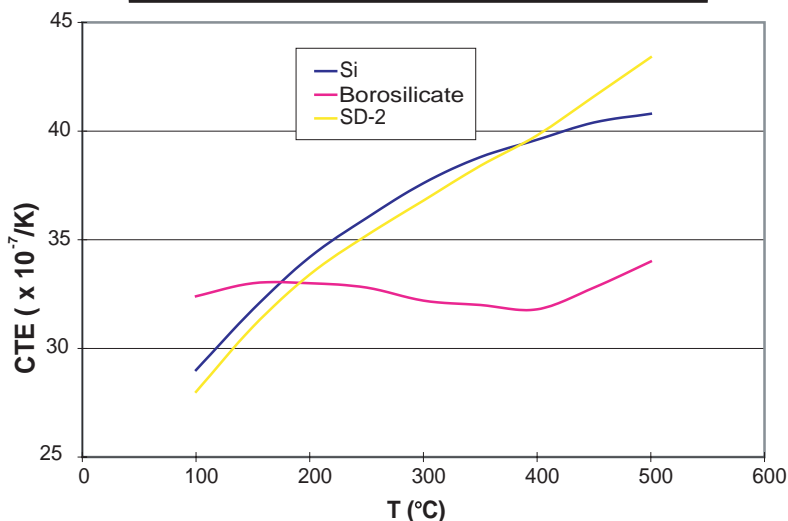
Silicon and glass wafers are generally put together by way of Anodic Bonding. This bonding is formed when positive (+) DC voltage is applied to the Si wafer and negative (-) is applied to the glass wafer while the wafers are pressed and heated. During the bonding process, a small amount of Na⁺ ions, engineered into SD-2, move as electroconductive carriers to facilitate a very short bonding time.

APPLICATIONS

- ▶ Silicon Wafer Bonding
- ▶ Photolithography
- ▶ Pressure Sensors
- ▶ Displacement Sensors
- ▶ Semiconductor



Coefficient of Thermal Expansion Curve



FEATURES

- ▶ Matching CTE to Si Wafer
- ▶ No Phase Separation
- ▶ Optimized for Anodic Bonding
- ▶ Reduced Fresnel Diffraction
- ▶ High Flatness Mask
- ▶ High Young's Modulus

HOYA CORPORATION USA
Optics Division
3400 Edison Way
Fremont, CA 94538

800-818-HOYA (4692)
510-252-8370
510-490-1988 fax
www.hoyaoptics.com

PRODUCT SPECIFICATIONS

Thermal Properties	Unit	SD-2	Borosilicate
▶ Coefficient of Thermal Expansion	$\times 10^{-7}/^{\circ}\text{C}$	32.0	32.5
▶ Transformation Point (T _g)	$^{\circ}\text{C}$	721	552
▶ Sag Point (T _s)	$^{\circ}\text{C}$	787	
▶ Strain Point	$^{\circ}\text{C}$	669	510
▶ Annealing Point	$^{\circ}\text{C}$	720	560
▶ Thermal Conductivity	Cal/sec·cm· $^{\circ}\text{C}$	0.0026	0.0027
▶ Specific Heat	Cal/g· $^{\circ}\text{C}$	0.176	0.180
Mechanical Properties	Unit	SD-2	Borosilicate
▶ Specific Gravity		2.60	2.23
▶ Young's Modulus	kgf/mm ²	8860	6400
▶ Modulus of Rigidity	kgf/mm ²	3560	
▶ Poisson's Ratio		0.244	0.200
▶ Knoop Hardness	kgf/mm ²	638	418
Electrical Properties	Unit	SD-2	Borosilicate
▶ Volume Resistivity	$^{\circ}\text{C}$	$\Omega\cdot\text{cm}$	
	20 $^{\circ}\text{C}$		4.1×10^{14}
	100 $^{\circ}\text{C}$		1.4×10^{16}
	200 $^{\circ}\text{C}$		4.2×10^{11}
			4.6×10^{11}
			3.8×10^9
			0.9×10^9
▶ Dielectric Coefficient	$^{\circ}\text{C}$		
	20 $^{\circ}\text{C}$		6.0
	100 $^{\circ}\text{C}$		4.8
	200 $^{\circ}\text{C}$		7.0
			4.9
			7.0
			5.1
▶ Dielectric Loss	$^{\circ}\text{C}$		
	20 $^{\circ}\text{C}$		1.0×10^{-2}
	100 $^{\circ}\text{C}$		5.5×10^{-3}
			1.9×10^{-2}
			1.0×10^{-2}
			4.9×10^{-2}
			2.9×10^{-2}
Chemical Properties	Unit	SD-2	Borosilicate
▶ Acid Durability	mg/cm ² (loss)	1.20	0.50
	(30% HNO ₃ 80 $^{\circ}\text{C}$ 50H)		
▶ Alkaline Durability	mg/cm ² (loss)	0.01	0.02
	(0.01N NaOH 50 $^{\circ}\text{C}$ 15H)		
Optical Properties	Unit	SD-2	Borosilicate
▶ Refractive Index (n_d)		1.531	1.474
▶ Abbe-Number (ν_d)		59	

Specifications subject to change without notice.



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